



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Ahn et al.

Title: STRUCTURE AND METHOD FOR DUAL GATE OXIDE THICKNESSES

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We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ A return postcard.
- ☒ An Amendment and Response (4 Pages).
- ☒ A Supplemental Information Disclosure Statement (1 pg.), Form 1449 (1 pg.), and copies of 2 cited references.
- ☒ A check in the amount of \$180.00 to cover the fee for consideration of Information Disclosure Statement under 97(c).
- ☒ A Copy of Page 2 of the initialed PTO Form 1449 filed on August 30, 2001 (1 pg.).

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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
P.O. Box 2938, Minneapolis, MN 55402 (612-373-6900)

By:
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P.O. Box 2938, Minneapolis, MN 55402 (612-373-6900)